

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Shoji MIYAKE et al.

Group Art Unit: 1792

Application No.: 10/539,254

Examiner: R. KACKAR

Filed: June 16, 2005

Docket No.: 123612

For: PLASMA GENERATOR, PLASMA CONTROL **MAIL STOP RCE**  
METHOD AND METHOD OF PRODUCING  
SUBSTRATE

**LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

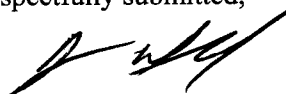
In accordance with the provisions of 37 C.F.R. §1.114, Applicants hereby request continued examination.

☒ Applicants further request entry and consideration of the attached Amendment.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

The fees associated with this filing are being paid electronically with this filing. The Commissioner is hereby authorized to charge any additional fee (or credit any overpayment) associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,



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JAO:ABW/can

Date: December 22, 2008

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<p><b>DEPOSIT ACCOUNT USE AUTHORIZATION</b> Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
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